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AMENDMENT UNDER 37 C.F.R §1.116  
EXPEDITED PROSECUTION - GROUP ART UNIT 1763

03500.013470

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*H11BNE*  
*4/23/03*  
*mw*

In re Application of:

TADASHI SAWAYAMA ET AL

Application No.: 09/294,367

Filed: April 20, 1999

For: PROCESSING APPRATUS,  
EXHAUST PROCESSING  
PROCESS AND PLASMA  
PROCESSING PROCESS

)  
: Examiner: Ran N. Kackar

)  
: Group Art Unit: 1763

)  
: **RECEIVED**  
**APR 22 2003**  
**GROUP 1700**  
: April 14, 2003

Commissioner for Patents  
Washington, D.C. 20231  
Box: AF

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action dated January 13, 2003, kindly  
amend the subject application as follows:

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope addressed  
to: Commissioner for Patents, Washington, D.C. 20231 on

April 14, 2003  
(Date of Deposit)

PETER SAXON (24947)  
(Name of Attorney for Applicant)

*Peter Saxon*  
Signature

April 14, 2003  
Date of Signature